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RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2826PATENT APPLICATION
Docket No.: 8750-064
Client Ref. No.: SPX200212-0002US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Ho-Ouk LEE and Hyo-Dong BAN

Serial No.: 10/803,064

Examiner: Quach, Tuan N.

Filed: March 16, 2004

Group Art Unit: 2826

Confirmation No.: 5182

For:

SEMICONDUCTOR DEVICES HAVING DUAL CAPPING LAYER
PATTERNS AND METHODS OF MANUFACTURING THE SAMEMail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450RESPONSE AFTER FINAL REJECTION UNDER 37 CFR 1.116

This paper is responsive to the Final Office Action (Paper No. 0905) that was mailed on 2 September 2005.

A Listing of Claims that reflects the current status of the claims begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

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